

Notice of References Cited

Applicant/Patent

Weimer et al.

Application/Control No.

09/296,835

Examiner

Erik Kielin

Art Unit

2813

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NON-PATENT DOCUMENTS

* Country Code-Number-Kind Code	Include, as applicable: Author, Title, Date, Publisher, Edition or Volume, Pertinent Pages
U	Van Zant, Microchip Fabrication, A Practical Guide to Semiconductor Processing, 3rd ed. McGraw-Hill: New York, 1997, pp. 157-160.
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* A copy of this reference is not being furnished with this Office action. See MPEP § 707.05(a).

¹ Dates in MM-YYYY format are publication dates.

² Classifications may be U.S. or foreign.